Situation with industry

Rui de Oliveira RD51 CERN 16-18 October 2013

<u>Outline</u>

- CERN team presentation
- Situation

CERN TEAM

- Serge Ferry
 - Vacuum deposition expert + Micromegas Micro-bulk
 - Ex: CAST detector
- Julie Veron
 - Large size Read-out boards expert
 - soon simulation
 - Ex: recent 1m x 0.5m 2D read-out for SOLID experiment (COMPASS like)
- Olivier Pizzirusso
 - Micromegas expert
 - Ex: MAMMA detector
- David Ranchin
 - Low mass inner tracker circuits expert
 - Examples soon. (training phase)
- Alexandra Gris
 - Low mass inner tracker circuits expert
 - Ex: IBL low mass bus ATLAS
- Alexis Rodrigues
 - GEM expert
 - GEM team leader (3 FSU persons)
 - Ex: Major help in setting up single mask technology
- Silvia Franchino
 - R&D, simulation
 - Examples soon (training phase)
- Antonio Teixeira
 - Competent in all technologies (section leader deputy)
 - Follows technically the Staff team

<u>Outline</u>

- CERN team presentation
- Situation
 - GEM
 - Micromegas
 - THGEMs

<u>GEM</u>

Large PCB procurement (valid for the 3 technologies):

Viasystem

- US company
- Multilayer boards size: 1.2m x 0.5m

ShenZhen SinoFast Electron Limited

- Chinese company
- Multilayer boards size: 1.3m x 0.5m

ELTOS

- Italian company
- •Single sided boards size: 2.3m x 0.5m
- Double sided boards size: 1.2m x 0.5m
- Multilayer boards size: 700mm x 0.5m

• ELVIA

- French company
- •Single sided boards size: 2.3m x 0.5m
- •Multilayer boards size: 700mm x 0.5m

We are trying to find more companies making large boards (any information from collaboration is welcome)

GEM in industry

Techtra

- Polish company
- Making GEM since 10 years
- Licensed by CERN
- •Setting up equipment for large GEM production since 1 year
- •30cm x 10cm GEMs already produced

• UPLUS/Mecharonics

- Korean company
- Making GEM since a few months
- Licensed By CERN
- •30cm x 30cm GEMs already produced (low quality)
- •Willing to ramp up to large size
- Willing to do mass production

• Tech-etch

- •US company
- Making GEM since 15 years
- Many small and medium sizes GEM have been produced
- Recently involved in STAR experiment (80 GEMs 40cmx40cm)
- •Active TT transfer with CERN to build large size foils
- Licensed by CERN
- •Ready for mass production with small and medium sizes

- Single mask test performed
- •10cm x 10cm GEM available
- Looking for volume

- •10cm x 10cm GEM produced
- Need to be qualified
- Exploring large size with 2 masks
- •Large size GEMs in a few months?

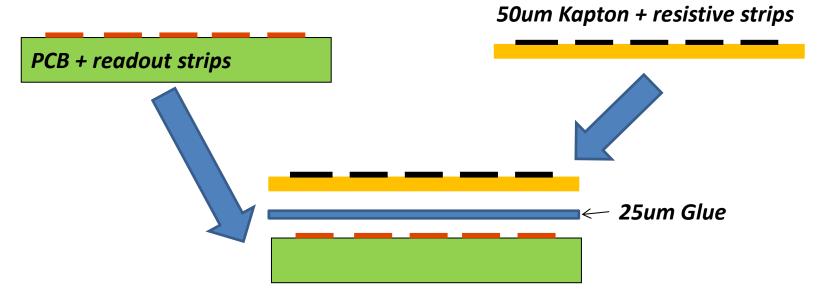
- Actively setting up the single mask process
- Already some positive trials have been performed
- Few months to get first single mask GEM
- •Weekly meeting with CERN

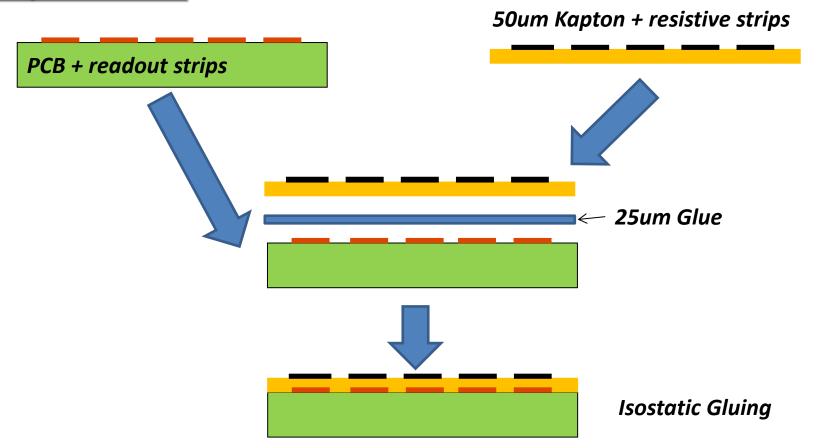
<u>Micromegas</u>

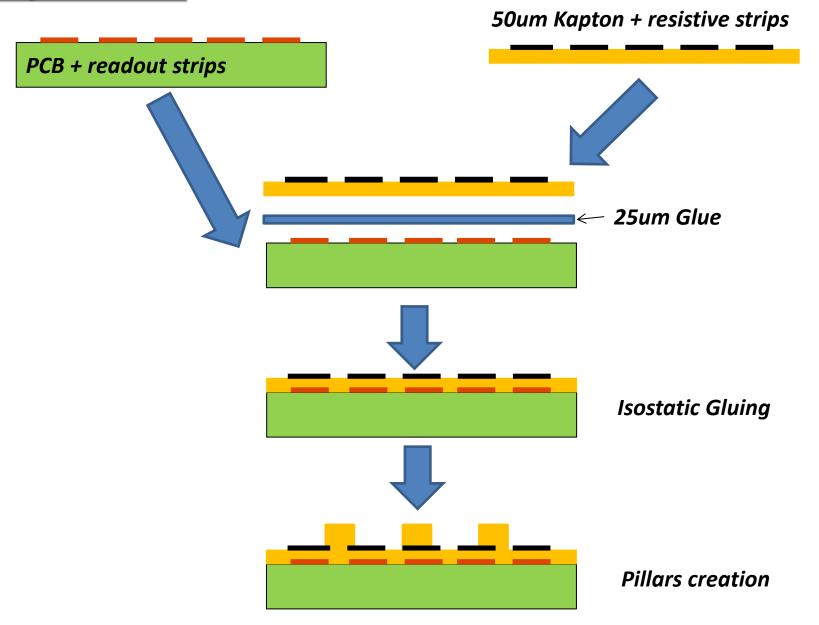
Let me remind you the last process for mass production

50um Kapton + resistive strips

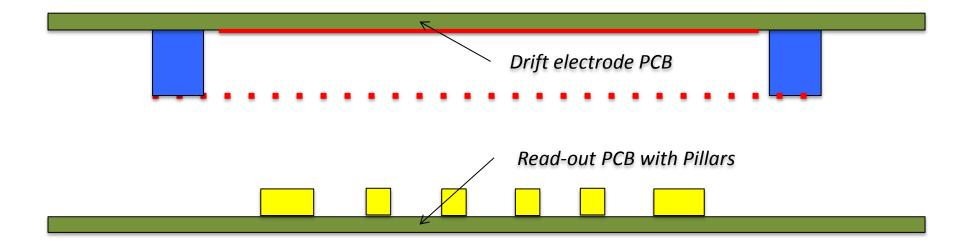
PCB + readout strips







Micromegas



PCB

• ELTOS

- •Quote request for 1200m2 (2.25m x 0.5m)
 - •Single axis
- •1.2m x 0.5m in production
 - •Single axis (MSW)test

• ELVIA

- •2 Boards LSBB project 1.2m x 0.5m in production (2D read-out)
- Quote request for large volume soon

PCB + readout strips

Resistive deposition

Charbonney

- •Swiss company near CERN doing screen printing
- •Printing 1m x 0.5m resistive strips → OK
- •Max possible size: 1.5m x 0.9m
- Mass Production → OK
- •MSW in production
- ATLAS MAMMA, LSBB and many small detectors have been produced
- Waiting for large volume quote

Raytech

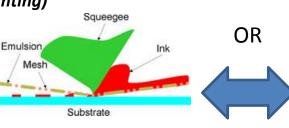
- Japanese company (Ochi Atsuhiko contact)
- Vacuum deposited resistive layers (lift off technique)
- •MSW in production

• ELVIA

•1.2m x 0.5m LSBB in production (Screen printing)

• ELTOS

- 1.2m x 0.5m MSW in production (Screen printing)
- Waiting for large volume quote

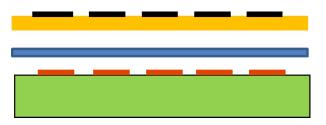




Large size gluing

•MDT

- Italian company having an extra large Isostatic press (similar process used at CERN)
- •Press gluing capability 4.2m x 1.6m \rightarrow to be tested
- Mass production → seems OK
- •Quotes for large volume not yet asked
- •We should organize a visit and probably make the MSW prototypes



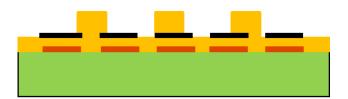
Pillar creation

• ELTOS

- •1.2m x 0.5m MSW Micromegas in production
- •Quote for 1200m2 requested

• <u>ELVIA</u>

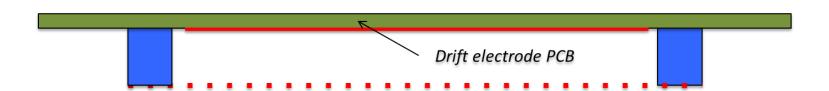
- •LSBB 1.2m x 0.5m real BULK in production
- •Quote for large volume still to be sent.



Mesh stretching

•Seritec

- •Swiss company near CERN stretching meshes
- •Stretching $2m \times 1m \text{ mesh } \rightarrow OK$
- •Max possible size: 3.2m x 2.2m
- Mass production → OK
- •We are studying the received quotes for 1200m2



THGEM

• ELTOS

- Drilling
 - •30 Hours /m2 for 1mm pitch
 - •Best case 2 to 3m2 per week without interfering with their core PCB production
 - Price reduction with volume is not really expected (still need to be clarified)
- Photolithography
 - OK
- Rims
 - OK
- Cleaning
 - We need to define a process and make trials
 - Polishing → long manual process
 - Spray polishing machine? (to be tested)
 - PU coating → shorter process but still manual
 - Automatic spray machine ? (to be tested)
 - Chemical process will be preferred → using existing equipment

Thank you

<u>questions</u>

- Any comment on the industrialisation?
- Will it be interesting to set up STD kit detectors?
 - 50cm x 50cm?
 - $-1m \times 0.5m$?
- Integrate the HV distribution Resistive hybrid to the STD 10cm x 10cm detectors?